

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Atty. Docket

RINK et al.

NL 031292

Serial No.

Group Art Unit

Filed: CONCURRENTLY

Ex.

METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE AND AN APPARATUS FOR
USE IN SUCH A METHOD

Commissioner for Patents
Alexandria, VA 22313-1450


AUTHORIZATION PURSUANT TO 37 CFR §1.136(a)(3)
AND TO CHARGE DEPOSIT ACCOUNT

Sir:

The Commissioner is hereby requested and authorized to treat any concurrent or future reply in this application requiring a petition for extension of time for its timely submission, as incorporating a petition for extension of time for the appropriate length of time.

Please charge any additional fees which may now or in the future be required in this application, including extension of time fees, but excluding the issue fee unless explicitly requested to do so, and credit any overpayment, to Deposit Account No. 14-1270.

Respectfully submitted,

By 
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